

Atty Docket No. OSP-10057
PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takeo MATSUKI et al.

Serial No. 09/764,880

Filed January 23, 2001

Confirmation No. 4114

GROUP 2818

Examiner Thinh Nguyen

SEMICONDUCTOR DEVICE STRUCTURE
AND METHOD FOR MANUFACTURING
THE SAME

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, D.C. 20231

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed sheet.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in an Office Action of May 28, 2002, a copy of which is attached hereto. An English translation of the portion enclosed in a wavy line is also attached hereto for the Examiner's convenience.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that no item contained in this Information Disclosure Statement was known to any individual.

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P. Walker
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MATSUKI et al. - S.N. 09/764,880

designated in §1.56(c), more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

By



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August 1, 2002

FORM PTO-1449 U.S. DEPARTMENT OF
COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.

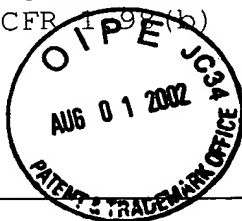
OSP-10057

SERIAL NO.

09/764,880

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use several sheets if necessary)
(37 CFR 1.97(b))



APPLICANT

Takeo MATSUKI et al.

FILING DATE

January 23, 2001

GROUP

2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE <small>IF APPROPRIATE</small>
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
	AL	62-262443	11/87	Japan			No
	AM	9-232251	9/97	Japan			No
	AN	11-97528	4/99	Japan			No
	AO						
	AP						

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AR	
	AS	
	AT	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.